

IMPACT FACTOR 3.0

Indexed in: PubMed



an Open Access Journal by MDPI

Laser Micro- and Nano- Processing

Guest Editors:

Dr. Maria Farsari

IESL-FORTH, 100 N.Plastira str., Vassilika Vouton, 70013 Heraklion, Crete, Greece

Prof. Dr. Costas Fotakis

IESL-FORTH, 100 N.Plastira str., Vassilika Vouton, 70013 Heraklion, Crete, Greece

Deadline for manuscript submissions:

closed (31 July 2014)

Message from the Guest Editors

Dear Colleagues,

Numerous recent technological advances rely on controllable micro- and nano-fabrication techniques to improve the performance of devices in various applications (e.g., in biomedicine, communications, and energy harvesting). Lasers are uniquely suited for a wide variety of fabrication applications at both the micro- and the nanoscales, in both the production and research environments. In light of this, we announce a Special Issue on "Laser Micro- and Nano Processing" and invite original contributions. We seek not only to report recent developments, but also to mold the future of the field. Example topics include matter interactions, direct write processes, ultra-short pulse laser processing, surface treatment, and 3-D micro- and nano-fabrication.

We look forward to receiving your contributions.

Prof. Dr. Costas Fotakis Dr. Maria Farsari *Guest Editors*













an Open Access Journal by MDPI

Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Author Benefits

Open Access: free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility: indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, dblp, and other databases.

Journal Rank: JCR - Q2 (Instruments and Instrumentation) / CiteScore - Q2 (Electrical and Electronic Engineering)

Contact Us